



XA-9387  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hitoshi TAKEUCHI

Appln. No.: 09/714,183

Group Art Unit: 2877

Filed: November 17, 2000

Examiner: R. Punnoose

For: ABERRATION MEASURING APPARATUS, ABERRATION MEASURING METHOD, PROJECTION EXPOSURE APPARATUS HAVING THE SAME MEASURING APPARATUS, DEVICE MANUFACTURING METHOD USING THE SAME MEASURING METHOD, AND EXPOSURE METHOD

Allowed: December 15, 2003

Confirmation No.: 5906

REQUEST FOR PRIORITY ACKNOWLEDGEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Attn: Mail Stop Issue Fee

Sir:

Applicants respectfully request acknowledgement of the certified copy of the priority document (Japanese Application No. 10-153915) which was filed on November 17, 2000, as indicated by the accompanying copy of the postcard receipt. The Notice of Allowability mistakenly indicates that the certified copy was not received.

Respectfully submitted,

MWS:lmb

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January 20, 2004

By:

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Reg. No. 31,568



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XA-9387  
P05622

The PTO date stamp acknowledges receipt of the paper(s) listed below:

Applicant: HITOSHI TAKEUCHI Atty: MWS

Serial No. Herewith DKT #: 47059-00091

For: ABERRATION MEASURING APPARATUS, ABERRATION...

☒ Specification # (62 pp) & claims (35)

☒ Combined Declaration, Petition & Power of Atty

☒ Drawings 9 sheets

☒ ~~Claim to Priority & Priority Document~~

☒ Check (\$ 1,500.00) # 32681

☒ Assignment

☒ Utility Patent Application Transmitted

☐ Trademark Application

☐ Amendment/Response

☐ Information Disclosure Statement

☐ Issue Fee Transmittal

☐ Notice of Appeal

☐ Petition to Extend

JC690 U.S. PTO

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11/17/00